

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY
APPLICANT

Atty. Docket No. (Opt.)

XDEV1100



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Applicant Martin E. Kordesch, et al.	
Application Number 09/682,151	Filed July 27, 2001
For Contact Method for Thin Silicon Carbide Epitaxial Layer and Semiconductor Devices Formed by Those Methods	
Group Art Unit Unknown	Examiner Unknown

3627

PDS

#3

11-7-01

R Shultz

Assistant Commissioner of Patents
Washington, D.C. 20231

Certification Under 37 C.F.R. §1.8

I hereby certify that the documents listed below are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on July 30, 2001.

Janice Pampell

Applicant respectfully requests, pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, that the art listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified application. A copy of the art is enclosed for the convenience of the Examiner. Furthermore, pursuant to 37 C.F.R. §§ 1.97(g) and (h), no representation is made that a search has been made or that this art is material to patentability of the present application.

While Applicant believes no fees are due, if any fees are due, the Commissioner is hereby authorized to charge Deposit Account No. 50-0456 of Gray Cary Ware & Freidenrich LLP.

Applicant respectfully submits that the claims of Applicant's above-referenced patent application are patentably distinguishable from these references.

Respectfully submitted,

Gray Cary Ware & Freidenrich LLP
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Dated: July 27, 2001
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